## Notice of References Cited Application/Control No. 10/593,289 Applicant(s)/Patent Under Reexamination OHNO, HIROMOTO Examiner LOUISA LAO Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-4,392,000 A	07-1983	Ryckaert et al.	570/104
*	В	US-4,770,714 A	09-1988	Buchwald et al.	134/40
*	C	US-5,268,120 A	12-1993	Michaud, Pascal	510/177
*	D	US-6,274,782 B1	08-2001	Ohno et al.	570/179
*	Е	US-6,544,319 B1	04-2003	Krouse et al.	95/126
*	F	US-2003/0191350 A1	10-2003	Ohno et al.	570/105
*	G	US-6,967,260 B2	11-2005	Ohno et al.	570/179
*	Ι	US-7,084,316 B2	08-2006	Ohno et al.	570/177
*	-	US-7,138,553 B2	11-2006	Ohno et al.	570/164
*	J	US-2006/0252970 A1	11-2006	Ohno et al.	570/178
*	K	US-2007/0135617 A1	06-2007	Ohno, Hiromoto	528/502.00R
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Ø					
	R					
	Ø					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	C					
	V					
	w					
	х					

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.